



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 18, 2026	
IGI Report Number	LG784630950
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	11.96 X 5.97 X 3.76 MM

GRADING RESULTS

Carat Weight	1.51 CARAT
Color Grade	D
Clarity Grade	VS 1

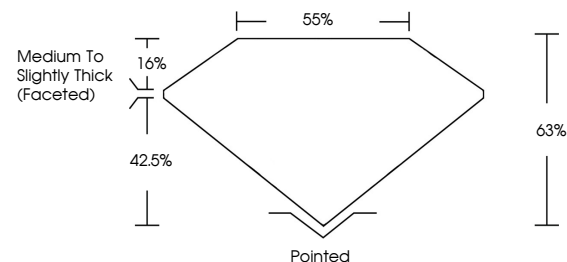
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG784630950

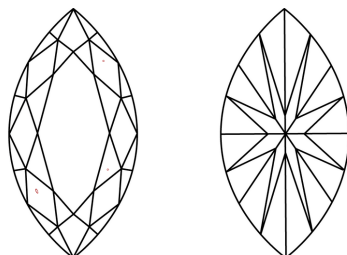
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG784630950
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

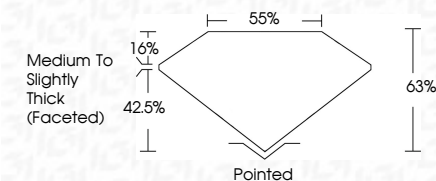
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March 18, 2026	1.51 CARAT
GI Report No.IG784430980	VVS 1
Color Weight	69%
Color Grade	59%
Clarity Grade	Medium to Slightly
Depth	Cut (Faceted)
Table	Polished
Grade	EXCELLENT
	symmetry
	fluorescence
	NONE
	461 (274430980)

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.

www.igi.org